



INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Attorney Docket Number	6454-56838-01
Application Number	10/039,552
Filing Date	October 26, 2001
First Named Inventor	Bowie G. Keefer
Art Unit	1754
Examiner Name	Maribel Medina Sanabria

U.S. PATENT DOCUMENTS

Examiner's Initials*	Cite No. (optional)	Number	Publication Date	Name of Applicant or Patentee
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MM		4,696,682	29 Sept 1987	Hirai et al.
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<p>* Examiner: Initial if reference considered, whether or not in conformance with MPEP 609. Draw line through cite if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>	



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